

Docket No.: 60188-835

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
<b>Takumi MIKAWA, et al.</b>	:	Confirmation Number:
	:	
Serial No.:	:	Group Art Unit:
	:	
Filed: April 14, 2004	:	Examiner:
	:	
For: SEMICONDUCTOR APPARATUS AND THE MANUFACTURING METHOD THEREOF	:	

**CLAIM OF PRIORITY**

Mail Stop CPD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

**Japanese Patent Application No. 2003-149444, filed May 27, 2003**

cited in the Declaration of the present application. A certified copy will be filed in due course.

Respectfully submitted,

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